520.41064X00 / NT0550US IN THE UNITED STATES PATENT AND TRADEMARK OFFICE applicant(s): HAMAMATSU, et al. Serial No .: 10/050,776 Filed: January 18, 2002 APPARATUS AND METHOD FOR INSPECTING DEFECTS For: Group: 2877 M. Stafira Examiner:

> Conf. No.: 9567

REQUEST FOR COMPLETE OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

February 14, 2006

Sir:

Receipt is acknowledged of the Office Action mailed January 25, 2006.

Upon review of the Office Action, it has been determined that the Office Action cannot be understood for the reason that the Office Action does not state that it is responsive to the Request for Continued Examination (RCE) and Amendment filed on November 16, 2005. A copy of the Request for Continued Examination (RCE), Amendment and postcard receipt are enclosed as proof of filing thereof.

Applicants request that the period for response be reset in accordance with the mail date of the complete Office Action.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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PJS/slk (703) 312-6600 Enclosures